



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

: **MAIL STOP: RCE**

Norio KIMURA et al.

: Docket No. 2001-0660A

Serial No. 09/864,208

: Group Art Unit 1763

Filed May 25, 2001

: Examiner Jeffrie R. Lund

SUBSTRATE POLISHING APPARATUS AND  
SUBSTRATE POLISHING METHOD

: **Confirmation No. 1632**

**PATENT OFFICE FEE TRANSMITTAL FORM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Attached hereto is a check in the amount of \$910.00 to cover Patent Office fees relating to filing the following attached papers:

Request for Continued Examination (RCE) ..... \$790.00

Petition for Extension of Time ..... \$120.00

A duplicate copy of this paper is being submitted for use in the Accounting Division, Office of Finance.

*The Commissioner is authorized to charge any deficiency or to credit any overpayment associated with this communication to Deposit Account No. 23-0975, with the EXCEPTION of deficiencies in fees for multiple dependent claims in new applications.*

Respectfully submitted,

Norio KIMURA et al.

THE COMMISSIONER IS AUTHORIZED  
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